

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/565,767	Confirmation No. 2990
Applicant	:	Yuichiro Shindo	
371 Filed	:	January 24, 2006	
Art Unit	:	1793	
Examiner	:	Mark L. Shevin	
Customer No.	:	00270	
Title	:	HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN FILM COMPRISING THE SAME, AND METHOD FOR PRODUCING HIGHLY PURE HAFNIUM	

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a Response being submitted with a Request for Continued Examination (RCE) in reply to a FINAL Office Action dated October 19, 2010. A Petition for a Three Month Extension of Time is filed herewith to extend the deadline for response from January 19, 2011 to April 19, 2011.

Remarks/Arguments begin on page 2 of this paper.